



Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet	1	of	2
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Complete if Known

Application Number	10/680,874
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Filing Date	October 6, 2003
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First Named Inventor	Farrrens, Sharon N.
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Art Unit	To Be Assigned	2329
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Examiner Name	To Be Assigned	Per
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Attorney Docket Number	18419D-009011US
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U.S. PATENT DOCUMENTS+

[illegible]

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	†
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
EP	0008	JP	03270209	A	12-02-1991	Fujitsu Ltd		<input checked="" type="checkbox"/>
EP	0009	WO	96/13060	A1	05-02-1996	Daimler-Benz Aktiengesellschaft	} Some translation + Figure	<input type="checkbox"/>
EP	0010	WO	99/10927	A1	03-04-1999	Farrens et al.		<input type="checkbox"/>
								<input type="checkbox"/>
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								<input type="checkbox"/>

**Examiner
Signature**

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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PTO/SB/08B (08-03)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Compleat If Known			
		Application Number	10/680,874		
		Filing Date	October 6, 2003		
		First Named Inventor	Farrens, Sharon N.		
		Art Unit	To Be Assigned 2829		
		Examiner Name	To Be Assigned Per		
Sheet	2	of	2	Attorney Docket Number	18419D-009011US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
EF	0011	Kissinger, G., and Kissinger, W. (1993) "Void-free silicon-wafer-bond strengthening in the 200-400 C range," Sensors and Actuators, Vol. A36, No. 2, pp. 149-156.	
EF	0012	Roberts, B.E. (1998). "Science and Technology of Plasma Activated Direct Wafer Bonding," PhD Dissertation, University of California at Davis, School of Engineering, pp. 1-120.	
EF	0013	Watt, V.H.C. and Bower, R.W., (1994). "Low Temperature Bonding Direct of Non-Hydrophilic Surfaces," Electronics Letters, pp. 693-695.	

Examiner Signature	<i>Even Per</i>	Date Considered	8-6-04
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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